

520.34403CV4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. MASUDA, et al

Serial No.: 09/421,043

Filed: October 20, 1999

Inventor: PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

Group: 1765

Examiner: D. Deo

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97 & 1.98

Commissioner for Patents
Washington, D.C. 20231

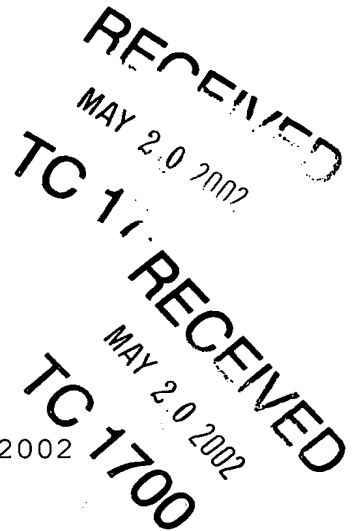
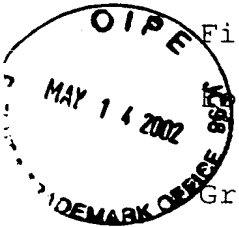
May 14, 2002

Sir:

In the matter of the above-identified application,
applicant(s) is/are submitting herewith a copy of documents
listed in the attached form equivalent to Form PTO-1449 for
the Examiner's consideration.

This information disclosure statement is being submitted
before the mailing date of a notice of allowance and is
accompanied by the fee of \$180.00 set forth in 37 CFR 1.17(p).

To the extent that, the documents listed on the attached
form equivalent to Form PTO-1449, are not in the English
language, the requirement of 37 CFR 1.98(a)(3) for a concise
explanation of the relevance is satisfied by an English
language abstract or corresponding U.S. patent of the
document.



It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (520.34403CV4) and please credit any excess fees to such deposit account.

Respectfully submitted,



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MK/cee
Attachments
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